

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Hong Sick Park et al. Examiner: Savitri Mulpuri  
Serial No: 10/516,602 Group Art Unit: 2812  
Filed: July 5, 2005 Docket: 8071-152T (OPP 031969US)  
For: **A METHOD OF FORMING A METAL PATTERN AND A  
METHOD OF FABRICATING TFT ARRAY PANEL BY USING  
THE SAME**

Mail Stop: RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Final Office Action dated September 13, 2006, please amend the above-referenced patent application as set forth herein. Also, accompanying this amendment is a Request for Continued Examination (RCE).

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